



ITW

3729/\$

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hajime AMANO et al.

Group Art Unit: 3729

Application No.: 09/818,565

Examiner: P. Kim

Filed: March 28, 2001

Docket No.: 109102

For: METHOD OF MANUFACTURING SPIN VALVE FILM

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the June 15, 2004 Office Action, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims;

Amendments to the Drawings include an attached replacement sheet; and

Remarks.